

S/ 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan

Examiner: Sylvia MacArthur

Serial No.: 09/652,713

Group Art Unit: 1763

Filed: August 31, 2000

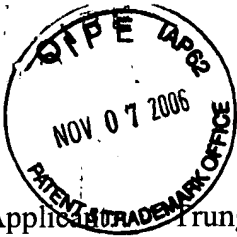
Docket No.: 303.928US5

Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER
PROCESSING

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This paper responds to the Office Action mailed on October 3, 2006. Please amend the
above-identified patent application as follows.



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4/26 176.3

Applicant: Trung T. Doan

Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING

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MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

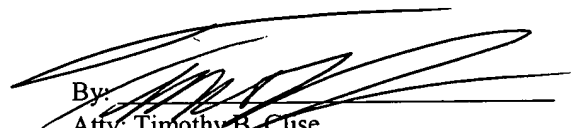
☒ Return postcard.

☒ Amendment and Response (8 pgs.).

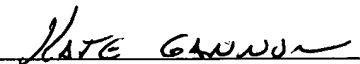
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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: 
Atty: Timothy B. Chase
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 2 day of November, 2006.


Name


Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)